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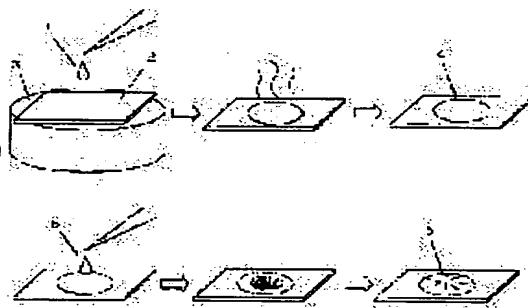
(21)Application number : 2001-225410 (71)Applicant : NATIONAL AGRICULTURAL
 RESEARCH ORGANIZATION
 NATIONAL FOOD RESEARCH
 INSTITUTE
 (22)Date of filing : 26.07.2001 (72)Inventor : OTOBE KAZUNORI
 NAKAO HIDENOBU
 OTANI TOSHIRO
 HAYASHI HIDEKI

(54) METHOD FOR PREPARING SUBSTRATE FOR MEASURING DNA

(57)Abstract:

PROBLEM TO BE SOLVED: To provide a substrate for measuring DNAs having highly flat surface, DNA adsorption properties, and DNA expansion properties.

SOLUTION: The preparation method of the substrate for measuring DNAs includes a process for forming the covering of a polymer that can be dissolved into a solvent or a polymer that has π conjugated binding, a process for dripping the DNA solution onto the covering, and a process for expanding the dripped DNA solution on the covering.



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